



S&H Form: (2/01) Attorney Docket No. 1082.1060

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Minoru HASEGAWA et al.

Application No.: 10/617,227

Group Art Unit: 2879

Confirmation No.: 2346

Filed: July 11, 2003

Examiner: Matthew P. Hodges

For:

SUBSTRATE ASSEMBLY FOR GAS DISCHARGE PANEL, PROCESS FOR

MANUFACTURING THE SAME, AND GAS DISCHARGE PANEL

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 17, 2004, applicants elect Claims 1-8 and 10 of Group I, without traverse.

Respectfully submitted,

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